

03500.014730.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
HIROSHI OHKURA ET AL.)	Previous Examiner: D. Chacko-Davis
Div. of Application No.: 09/649,598)	Previous Group Art Unit: 1756
Filed: Herewith)	
For: METHOD OF MANUFACTURING)		
STRUCTURE HAVING PORES :		June 30, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. In accordance with 37 C.F.R. § 1.98(d), copies of the documents available in Application No. 09/649,598, from which the present application claims benefit under 35 U.S.C. § 120, are not enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, in the specification where cited and/or in the English language abstracts attached thereto. Also, the concise explanation of relevance for JP 11-200090 may be found in the English translation, which was provided in the parent application.

The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/666,605	09/20/00	2811

09/178,680

10/26/98

2879

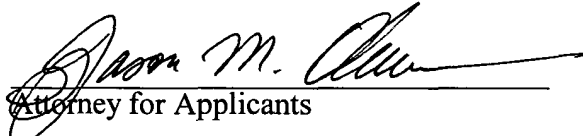
A copy of Application No. 09/666,605 has been provided in the parent case.
A copy of Application No. 09/178,680 is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants
Registration No. 48,512

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 03500.014730.1		APPLICATION NO. Div. of 09/649,598	
				APPLICANT HIROSHI OHKURA ET AL.			
				FILING DATE Herewith			GROUP N.Y.A.
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,139,713	10/31/00	Masuda et al.	205	206	
		6,278,231 B1	08/21/01	Iwasaki et al.	313	310	
		2002/0014621 A1	02/07/02	Den et al.	257	3	
		2002/0034662 A1	03/21/02	Den	428	692	
		6,476,409 B2	11/05/02	Iwasaki et al.	257	13	
		6,464,853 B1	10/15/02	Iwasaki et al.	205	118	
		6,214,738 B1	04/10/01	Aiba et al.	438	707	
		4,086,694	05/02/78	U	438	361	
		4,923,301	05/08/90	White	356	356	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	7-171984	07/11/95	Japan			Translation
	JP	11-200090	07/27/99	Japan			Abstract
	EP	0 931 859	07/28/99	Europe			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Hutley, M.C. "Coherent Photofabrication", Opt. Eng., Vol. 15, No. 3 (1976), pp. 190-196.					
		Decker, et al. "Generating...Reversal," J. Vac. Sci. Technol. B15(6), Nov. 1997 pp. 1949-1953.					
		Furneaux, et al. "The formation...aluminum", Nature, Vol. 337, P.147-149 (1989).					
		Masuda, "Anodically High Level"; Solid State Phys. , Vol. 3, No. 5, pp. 493-499 (1996).					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

